Transaction Information

Tool ID	MCIMP-10
Tool Status	Connected
Location	Singapore
Wafer Size	200 mm
Fab Section	Implant
Tool Available Date	2024-12-31

General Product Information

Vendor Supplier	Applied Materials South East Asia Pte. Ltd
Model	E500 EHP
Vintage	2007
Serial No	ES193877
Asset Description	F067PE0629M0X07
Software Version	13.42.18
CIM	GEM and SECS
Process	ION IMPLANTATION SYSTEM

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	Main Unit	1	
Others			
Handler System	Endstation PP+ with both LOADLOCK	1	
Options System			
Factory Interface	SMIF	0	OK

Hardware Configuration (Subfab / Auxilliary Units)

Quantity	Status
1	OK
1	OK
	Quantity 1

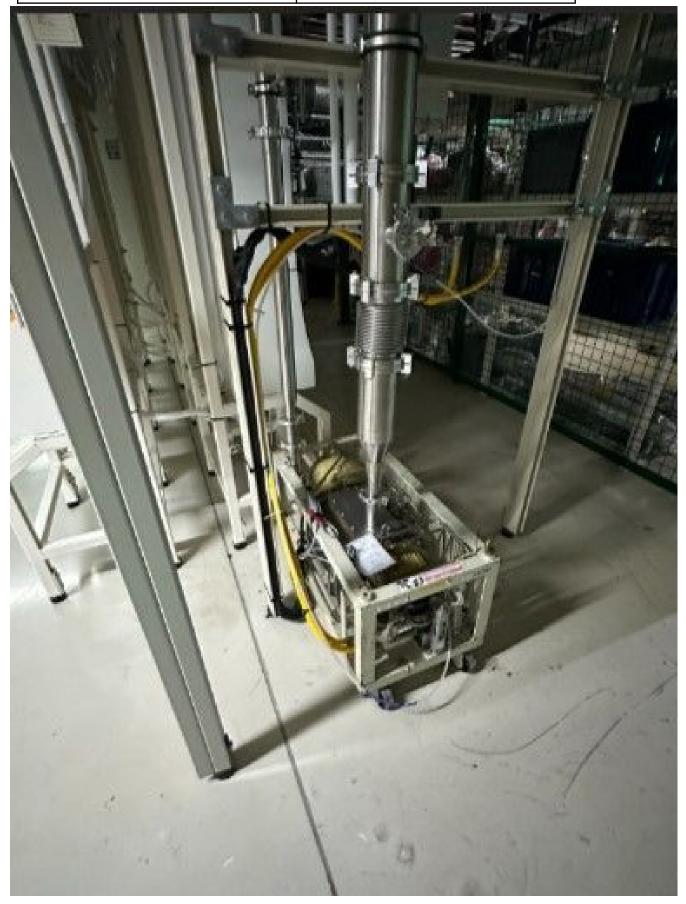
Missing/Faulty Parts / Accesorries List

Description	Quantity
Analyzer turbo pum	1
Load lock rough pump	1
Load lock rough pump	1
source rough pump	1
source turbo pump	1
LHS and RHS turbo pump	2
Scroll pump	1
Beamline turbo pump	1

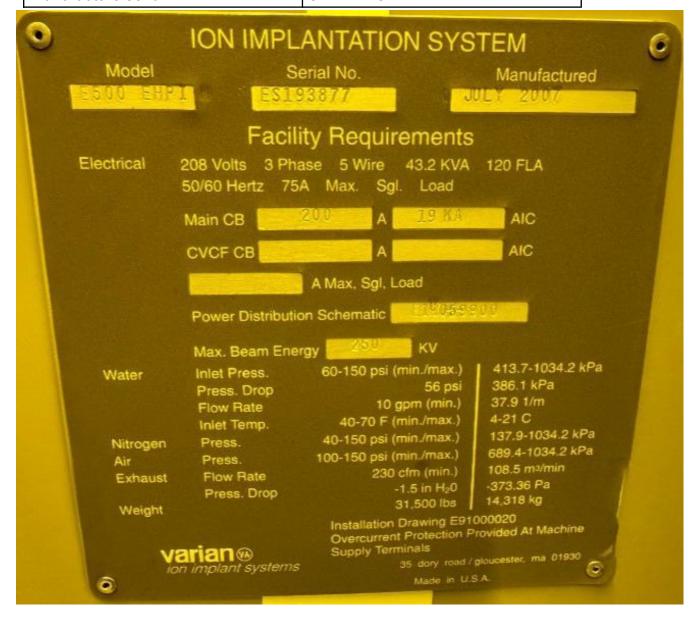
Tool Pictures General main machine Hardware Fab

Endstation with PP+ on both LOADLOCK



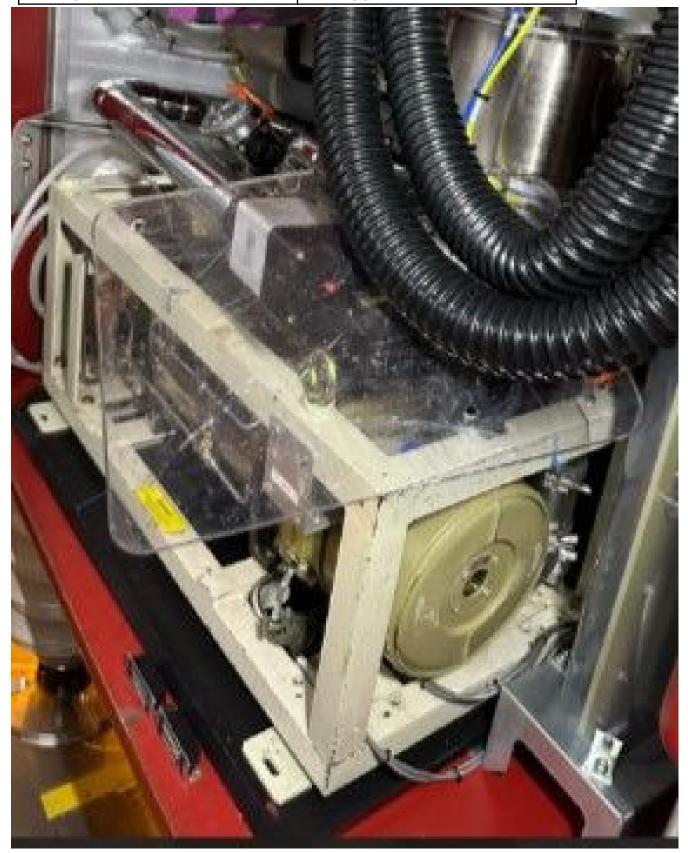


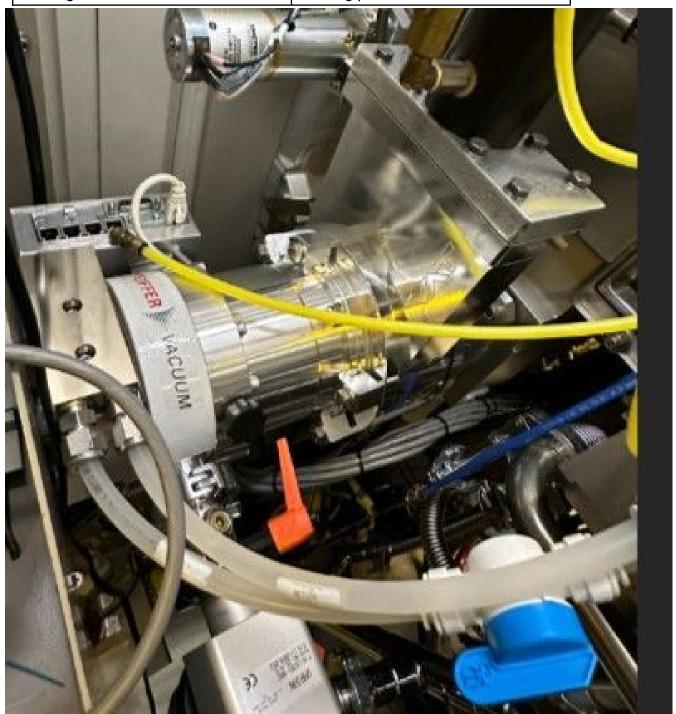


















Additional Tool Data Files